



ORGANISATION  
MONDIALE  
DU COMMERCE

Référence: WLI/100

7 décembre 2015

**ACCORD DE MARRAKECH INSTITUANT L'ORGANISATION  
MONDIALE DU COMMERCE  
FAIT À MARRAKECH LE 15 AVRIL 1994**

**ACCORD GÉNÉRAL SUR LES TARIFS DOUANIERS  
ET LE COMMERCE DE 1994**

**CERTIFICATION DE MODIFICATIONS ET DE RECTIFICATIONS  
LISTE LXXV – PHILIPPINES**

**ENVOI DE COPIE CERTIFIÉE CONFORME**

J'ai l'honneur de vous faire parvenir ci-joint une copie certifiée conforme des modifications et des rectifications apportées à la **Liste LXXV – Philippines**, qui ont pris effet le **20 novembre 2015**.

Roberto Azevêdo  
Directeur général



**LISTES DE CONCESSIONS TARIFAIRES ANNEXÉES À L'ACCORD GÉNÉRAL  
SUR LES TARIFS DOUANIERS ET LE COMMERCE DE 1994**

**CERTIFICATION DE MODIFICATIONS ET DE RECTIFICATIONS**

**LISTE LXXV – PHILIPPINES**

CONSIDÉRANT que les PARTIES CONTRACTANTES à l'Accord général sur les tarifs douaniers et le commerce de 1947 ont adopté, le 26 mars 1980, une Décision sur les procédures de modification et de rectification des listes de concessions tarifaires (IBDD, S27/26-27);

CONSIDÉRANT que, conformément aux dispositions de la Décision susmentionnée, un projet contenant les modifications et les rectifications apportées à la **Liste LXXV – Philippines** a été communiqué à tous les Membres de l'Organisation mondiale du commerce sous couvert du document G/MA/TAR/RS/421 le 20 août 2015 et qu'aucune objection concernant les modifications et les rectifications proposées n'a été reçue dans les trois mois suivant la date de publication dudit document;

IL EST CERTIFIÉ PAR LA PRÉSENTE que les modifications et les rectifications apportées à la **Liste LXXV – Philippines** sont établies conformément à la Décision susmentionnée.

La Liste jointe en annexe a pris effet le **20 novembre 2015**.

Je remets par la présente une copie certifiée conforme des modifications et des rectifications susmentionnées à chaque Membre de l'Organisation mondiale du commerce. La présente certification sera enregistrée conformément aux dispositions de l'article 102 de la Charte des Nations Unies.

FAIT à Genève, le dix-sept novembre deux mille quinze.

Roberto Azevêdo  
Directeur général

Copie certifiée conforme:

Directeur général



# **SCHEDULE LXXV - PHILIPPINES**

20 November 2015

**SCHEDULE LXXV - PHILIPPINES**

**This Schedule is authentic only in the English language**

**PART I - MOST-FAVORED-NATION TARIFF**

**SECTION II - Other Products**

<b>HS1996</b>	<b>Description</b>	<b>Base rate</b>	<b>Final bound rate</b>	<b>Implementation</b>	<b>INR</b>	<b>Other duties and charges</b>
7017	Laboratory, hygienic or pharmaceutical glassware, whether or not graduated or calibrated					
70171000	- Of fused quartz or other fused silica		10			0
702000	Other articles of glass					
702000ex	- Quartz reactor tubes and holders designed for insertion into diffusion and oxidation furnaces for production of semiconductor wafers		0			0
702000ex	- Other		Unbound			Unbound
8456	Machine-tools for working any material by removal of material, by laser or other light or photon beam, ultrasonic, electro-discharge, electro-chemical, electron beam, ionic-beam or plasma arc processes.					
845610	- Operated by laser or other light or photon beam processes					
84561000ex	- - Machines for working any material by removal of material, by laser or other light or photo beam in the production of semiconductor wafers		0			0
84561000ex	- - Lasercutters for cutting contacting tracks in semiconductor production by laser beam		0			0
84561000ex	- - Other		20			0
84569	- Other:					
845699	- - Other					
84569900ex	- - - Focused ion beam milling machines to produce or repair masks and reticles for patterns on semiconductor devices		0			
84569900ex	- - - Other		20			0
8479	Machines and mechanical appliances having individual functions, not specified or included elsewhere in this Chapter.					
84798	- Other machines and mechanical appliances:					
847989	- - Other					
84798900ex	- - - Apparatus for wet etching, developing, stripping or cleaning semiconductor wafers and flat panel displays		0			0
84798900ex	- - - Epitaxial deposition machines for semiconductor wafers		0			0
84798900ex	- - - Encapsulation equipment for assembly of semiconductors		0			0
84798900ex	- - - Die attach apparatus, tape automated bonders, and wire bonders for assembly of semiconductors		0			0
84798900ex	- - - Apparatus for growing or pulling monocrystal semiconductor boules		0			0
84798900ex	- - - Spinners for coating photographic emulsions on semiconductor wafers		0			0
84798900ex	- - - Machines for bending, folding and straightening semiconductor leads		0			0

HS1996	Description	Base rate	Final bound rate	Implementation	INR	Other duties and charges
84798900ex	- - - Other machines and mechanical appliances having individual functions, not elsewhere specified or included in Chapter 84		20			0
847990	- Parts					
84799000ex	- - Parts of automated machines for transport, handling and storage of semiconductor wafers, wafer cassettes, wafer boxes, and other material for semiconductor devices		0			
84799000ex	- - Parts of encapsulation equipment for assembly of semiconductors		0			
84799000ex	- - Parts of epitaxial deposition machines for semiconductor wafers		0			
84799000ex	- - Parts of apparatus for growing or pulling monocrystal semiconductor boules		0			
84799000ex	- - Parts of machines for bending, folding and straightening semiconductor leads		0			
84799000ex	- - Parts of apparatus for wet etching, developing, stripping or cleaning semiconductor wafers and flat panel displays		0			
84799000ex	- - Parts for spinners for coating photographic emulsions on semiconductor wafers		0			
84799000ex	- - Parts for die attach apparatus, tape automated bonders, and wire bonders for assembly of semiconductor		0			
84799000ex	- - Parts of machines and mechanical appliances having individual functions, not elsewhere specified or included in Chapter 84		20			
8543	Electrical machines and apparatus, having individual functions, not specified or included elsewhere in this Chapter					
85438	- Other machines and apparatus:					
854389	- - Other					
85438910ex	- - - Automatic ignition assembly consisting of transformer, wiring, ceramic igniters and push button switch, used as component parts in the manufacture of non-electric		20			
85438910ex	- - - Flat panel displays (including LCD, Electro Luminescence, Plasma and other technologies) for products falling within this agreement, and parts thereof		0			
85438910ex	- - - Electrical machines with translation or dictionary functions		0			
85438910ex	- - - Projection type flat panel display units used with automatic data processing machines which can display digital information generated by the central processing unit		0			
85438910ex	- - - Apparatus for physical deposition by sputtering on semiconductor wafers		0			
85438910ex	- - - Physical deposition apparatus for semiconductor production		0			
854390	- Parts					
85439000ex	- - Parts of ion implanters for doping semiconductor materials		0			
85439000ex	- - Parts of apparatus for wet etching, developing, stripping or cleaning semiconductor wafers and flat panel displays		0			
85439000ex	- - Parts of apparatus for physical deposition by sputtering on semiconductor wafers		0			
85439000ex	- - Parts of physical deposition apparatus for semiconductor production		0			
85439000ex	- - Parts of electrical machines and apparatus of heading No. 85.43		20			